AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Serial Number: 09/967138

Filing Date: September 28, 2001

Title: PRINTHEAD WITH SECURELY COUPLED BARRIER LAYER TO SUBSTRATE (As Amended)

## **IN THE CLAIMS**

Page 3 Dkt: 10981366-2 (1683.068US1)

Please amend the claims as follows:

1. (Withdrawn) A method for securely anchoring a barrier layer to a substrate in a fluid ejection device comprising:

applying a lower layer comprised of a first metal to a substrate having a fluid ejector; applying an upper layer comprised of a second metal to said lower layer;

etching said upper layer in order to remove a plurality of portions thereof while leaving a plurality of other portions of said upper layer intact, said etching of said upper layer also exposing multiple regions of said lower layer;

etching said multiple regions of said lower layer that were exposed after said etching of said upper layer in order to remove said multiple regions and produce a plurality of structures positioned on said substrate, said structures being spaced apart from each other and each comprising an etched section of said lower layer and a section of said upper layer thereon;

etching at least one of said structures on said substrate in order to remove said section of said upper layer therefrom and thereby produce an anchor member; and

covering said structures, said anchor member, and exposed portions of said substrate therebetween with a layer of at least one fluid barrier material, said anchor member securely attaching said layer of fluid barrier material to said substrate.

- 2. (Withdrawn) The method of claim 1 wherein said first metal used in said lower layer is selected from the group consisting of tantalum, aluminum, rhodium, chromium, titanium, molybdenum, and mixtures thereof.
- 3. (Withdrawn) The method of claim 1 wherein said second metal used in said upper layer is selected from the group consisting of gold, aluminum, rhodium, and mixtures thereof.
- 4. (Withdrawn) The method of claim 1 wherein said lower layer comprised of said first metal has a thickness of about 0.3 1.0 μm.

Serial Number: 09/967138

Filing Date: September 28, 2001

Title: PRINTHEAD WITH SECURELY COUPLED BARRIER LAYER TO SUBSTRATE (As Amended)

- 5. (Withdrawn) The method of claim 1 wherein said upper layer comprised of said second metal has a thickness of about 0.2 1.3 μm.
- 6. (Withdrawn) The method of claim 1 wherein said first metal is different from said second metal.
- 7. (Withdrawn) The method of claim 1 further comprising heating said fluid barrier material to a temperature sufficient to cause said fluid barrier material to flow around said anchor member.
- 8. (Withdrawn) The method of claim 7 wherein said temperature sufficient to cause said fluid barrier material to flow around said anchor member is about 50 500 °C.
- 9. (Currently Amended) A method for securely anchoring a barrier layer to a substrate in a printhead comprising:

forming at least one <u>extending</u> metallic anchor member <u>supported by</u> on a substrate having a fluid ejector thereon; and

covering said anchor member with a layer of at least one fluid barrier material, said anchor member securely attaching said layer of fluid barrier material to said substrate.

Claim 12 (Canceled).

13. (Currently Amended) A method for securely anchoring a barrier layer to a substrate in a printhead comprising:

applying at least one layer comprised of metal to a substrate having a fluid ejector; forming, with said layer, at least one extending metallic anchor member on said layer; and

covering said anchor member with a layer of at least one fluid barrier material, said anchor member securely attaching said ink barrier material to said substrate.

Page 5

Title: PRINTHEAD WITH SECURELY COUPLED BARRIER LAYER TO SUBSTRATE (As Amended)

Claims 14-19 (Canceled).

20. (Previously Presented) A method of forming a fluid ejection device comprising:

disposing a mechanical intercoupling structure on a substrate at least one fluid ejector

thereon;

disposing a chamber layer over said substrate, wherein side walls of an ejection chamber

are defined with the chamber layer;

substantially embedding said mechanical intercoupling structure with the chamber layer;

and

encapsulating the mechanical intercoupling structure with the substrate and the chamber

layer.

21. (Previously Presented) The method of claim 20, wherein said mechanical intercoupling

structure secures said chamber layer to said substrate.

22. (Previously Presented) The method of claim 20, wherein said mechanical intercoupling

structure is comprised of a metal.

23. (Previously Presented) The method of claim 22, wherein said mechanical intercoupling

structure includes at least one of the metals tantalum, aluminum, rhodium, chromium, titanium,

molybdenum, tungsten, platinum, and palladium.

24. (Previously Presented) The method of claim 20, wherein said chamber layer covers a

conductive trace, wherein said chamber layer is a fluid barrier that substantially hinders

interaction of a fluid with said conductive trace.

25. (Previously Presented) The method of claim 20, wherein said chamber layer comprises

an electrically insulative material.

Title: PRINTHEAD WITH SECURELY COUPLED BARRIER LAYER TO SUBSTRATE (As Amended)

(Previously Presented) The method of claim 20, wherein said chamber layer comprises a 26.

polymer.

27. (Previously Presented) The method of claim 20, wherein said mechanical intercoupling

structure is substantially hour-glass shaped in that the structure has top and bottom surfaces, and

a narrowed portion therebetween.

28. (Previously Presented) The method of claim 20, wherein said mechanical intercoupling

structure includes a concave side wall.

(Previously Presented) The method of claim 20, wherein said concave side wall is 29.

curved.

(Previously Presented) The method of claim 20, wherein said mechanical intercoupling 30.

structure includes: a top surface defining a top surface width; a bottom surface; and a central

portion between the top surface and the bottom surface defining a width that is less than the top

surface width.

31. (Previously Presented) A method of coupling a barrier layer to a substrate of a fluid

ejection device comprising:

positioning at least one metallic anchor member on a substrate;

positioning a layer of barrier material over the substrate and the at least one metallic

anchor member;

substantially embedding said at least one metallic anchor member with the layer of

barrier material; and

encapsulating the at least one metallic anchor member with the substrate and the barrier

layer.

32. (Previously Presented) The method of claim 31, wherein said metallic anchor member

secures said layer of barrier material to said substrate.

Page 7
Dkt: 10981366-2 (1683.068US1)

33. (Previously Presented) The method of claim 31, wherein said metallic anchor member further includes:

a first metal layer disposed on a portion of said substrate; and

a second metal layer disposed on at least a portion of said first metal layer, and wherein said second metal layer is different from said first metal layer.

- 34. (Previously Presented) The method of claim 33, wherein said metallic anchor member is substantially hour-glass shaped in that the structure has top and bottom surfaces, and a narrowed portion therebetween.
- 35. (Previously Presented) The method of claim 31, wherein said metallic anchor member includes a concave side wall.
- 36. (Previously Presented) The method of claim 35, wherein said concave side wall is curved.
- 37. (Previously Presented) The method of claim 31, wherein said metallic anchor member includes:
  - a top surface defining a top surface width;
  - a bottom surface; and
- a central portion between the top surface and the bottom surface defining a width that is less than the top surface width.
- 38. (Previously Presented) A method of forming a fluid ejection cartridge comprising: fluidically coupled a fluid reservoir with a fluid ejection device, wherein the fluid ejection device has a substrate having at least one fluid ejector thereon, a mechanical intercoupling structure disposed on said substrate, and a firing chamber layer disposed on said substrate and defining side walls of a firing chamber; and

Title: PRINTHEAD WITH SECURELY COUPLED BARRIER LAYER TO SUBSTRATE (As Amended)

substantially embedding said mechanical intercoupling structure into the firing chamber

layer; and

encapsulating the mechanical intercoupling structure with the substrate and the firing

chamber layer.

39. (Previously Presented) The method of claim 38, wherein said mechanical intercoupling

structure secures said firing chamber layer to said substrate.

40. (Previously Presented) The method of claim 38, wherein said mechanical intercoupling

structure is comprised of a metal.

41. (Previously Presented) The method of claim 38, wherein said mechanical intercoupling

structure includes: a first metal layer disposed on a portion of said substrate; and a second metal

layer disposed on at least a portion of said first metal layer, and wherein said second metal layer

is different from said first metal layer.

42. (Previously Presented) The method of claim 38, wherein said mechanical intercoupling

structure is substantially hour-glass shaped in that the structure has top and bottom surfaces, and

a narrowed portion therebetween.

43. (Previously Presented) The method of claim 42, wherein said mechanical intercoupling

structure includes a concave side wall.

44. (Previously Presented) The method of claim 43, wherein said concave side wall is

curved.

45. (Previously Presented) A method of coupling a barrier layer to a substrate of a fluid

ejection device comprising:

forming a fluid ejector on a first area of said substrate;

Dkt: 10981366-2 (1683.068US1)

Title: PRINTHEAD WITH SECURELY COUPLED BARRIER LAYER TO SUBSTRATE (As Amended)

disposing the barrier layer over a second area that surrounds the first area, wherein the barrier layer surrounds said fluid ejector;

a substrate having a first area surrounded by said second area; coupling said barrier layer to said substrate in the second area with an anchor means; and encapsulating the anchor means with the substrate and the barrier layer.

46. (Previously Presented) The method of claim 45, wherein said anchor means includes an anchor member extending from said substrate and encompassed by said barrier layer, wherein said anchor member has a concave and curved side wall.